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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: Nakayama

FILED: June 14, 2000

FOR: Semiconductor Storage Device

DOCKET: NEC DP-624

BOX PATENT APPLICATION
The Commissioner of Patents & Trademarks
Washington, D.C. 20231

PRIOR ART DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicant hereby attaches U.S. Patent Office Form PTOL-1449, including a copy of the prior art reference listed therein. This reference is discussed in the specification. The claims in the present application are believed to be patentably distinguished over this reference.

This prior art disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitute prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,

Norman P. Soloway
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Reg. No. 24,315